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PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2811**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi YAMAZAKI et al.

Group Art Unit: 2811

Application No.: 09/970,766

Examiner: S. Hu

Filed: October 5, 2001

Docket No.: 110791

For: METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE,
SEMICONDUCTOR SUBSTRATE, ELECTRO-OPTICAL APPARATUS AND
ELECTRONIC EQUIPMENT

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the April 22, 2004 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.